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利用形態 :共同研究

利用課題名(日本語)

Program Title(English) : Tuning Plasmon-Enhanced Photocurrent Generation by the Interference in TiO₂

Thin-film

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1. 概要(Summary)

Thin-film solar harvesting system is prospecting for next generation solar cell. The TiO₂ thin film was fabricated by atomic layer deposition, a well-controlled thin film thickness and perfect step coverage deposition method, on a 50-nm aluminum thin film coated silica glass. The gold nano-islands (Au-NIs) structure, which exhibits characteristic plasmon resonance, were subsequently decorated on the surface of TiO2 thin film by sputtering a 3-nm gold thin film and annealing at 250°C. Due to the large difference of refractive index, TiO2 thin film exhibited a strong interference.^[1] When the transmission constructive interference overlap with the plasmon resonance of Au-NIs, the plasmon-enhanced photocurrent generation on Au-NIs/TiO₂ system could be enormously increased.

2. 実験(Experimental)

【利用した主な装置】

ALD (Picosun SUN ALE-R), Helicon Sputtering (ULVAC MPS-4000C1/HC1, SEM (JEOL JSM-6700FT), STEM/TEM (JEOL ARM 200F)

【実験方法】

A 50-nm Al thin film was thermal evaporated on the surface of silica glass. TiO₂ thin films were deposited onto the Al coated silica glass by ALD (SUNALETM R series, Picosun, Finland). Sequentially, a 3-nm gold thin film was evaporated and then annealed in H₂ (3.9% in Ar) at 250°C for 2 hours. The surface morphology of the Au-NIs/TiO₂ were observed by field-emission scanning electron microscopy (FE-SEM, JSM-6700FT, JEOL). The cross-section analysis was carried out with a JEOL ARM200F aberration corrected TEM/STEM equipment.

3. 結果と考察 (Results and Discussion)

A highly corresponding of the IPCE action spectra bands to the (1-R) spectra of TiO₂ thin films is shown in Figure 1, which indicates a tunable plasmon-enhanced photocurrent generation can be implemented by

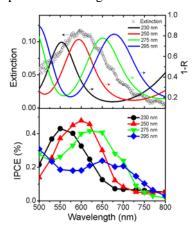


Fig. 1 Extinction spectrum of Au-NIs, and (1-R) Spectra and IPCE of Au-NIs/TiO₂/Al

controlling the interference in TiO₂ thin film. The IPCE dependence on the overlap of (1-R) of TiO₂ thin film and the extinction of Au-NIs further illustrates that photocurrent the generated on Au-NIs/TiO₂ originated plasmon from the

resonance of Au-NIs.

4. その他・特記事項(Others)

共同研究者

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- •参考文献
- (1) X. Shi eta al., J. Phys. Chem. C 117, 2494-2499 (2013)..

5. 論文・学会発表 (Publication/Presentation)なし

6. 関連特許(Patent) なし